

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Priority Application Serial No. 09/945,137
Priority Filing Date August 30, 2001
Inventor..... Jerome M. Eldridge
Assignee..... Micron Technology, Inc.
Priority Group Art Unit 2822
Priority Examiner K. Duong
Attorney's Docket No. MI22-2496
Title: Perovskite-Type Material Forming Methods, Capacitor Dielectric Forming Methods,
and Capacitor Constructions

PRELIMINARY AMENDMENT

To: MS Patent Application
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

From: James E. Lake (Tel. 509-624-4276; Fax 509-838-3424)
Wells St. John P.S.
601 W. First Avenue, Suite 1300
Spokane, WA 99201-3828

AMENDMENTS

EL 979954434